

Search Notes

Application/Control No.

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Examiner

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Applicant(s)/Patent under
Reexamination

CHU, WEN-HWA LIN

Art Unit

3682

SEARCHED

Class	Subclass	Date	Examiner
74	594.4- 594.7	3/15/2006	CK

INTERFERENCE SEARCHED

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**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR